Electrical resistivity of solid and liquid Cu up to 5 GPa: Decrease along the melting boundary

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Abstract

The electrical resistivity of high purity Cu has been investigated by both experiments and first principle calculations at pressures up to 5 GPa and at temperatures in the liquid phase up to 1730 K. The resistivity decreases with P and increases with T and our data are in very good agreement in relation to 1 atm data. Our melting temperature data agree with other experimental studies. We show that resistivity of Cu decreases along the P,T-dependent melting boundary in disagreement with prediction of resistivity invariance along the melting boundary. These findings are interpreted in terms of the competing effects of P and T on the electronic structure of liquid Cu. The electronic thermal conductivity is calculated from resistivity data using the Wiedemann-Franz law and is shown to increase with P in both the solid and liquid phases up to 1730 K. The resistivity decreases with P and increases with T and our data are in very good agreement in relation to 1 atm data. Our melting boundary predictions are in agreement with experiment and theory.

1. Introduction

Electrical resistivity and thermal conductivity of metals characterize the nature of electron-phonon and electron-electron interaction as well as the phase state of a system. The effects of pressure (P) and temperature (T) on the electrical resistivity of a metal are usually antagonistic – resistivity decreases with P and increases with T. Combinations of P and T that offset each other to maintain constant resistivity can be found if the P- and T-coefficients of resistivity are known. A thermodynamically-based treatment of the effects of P and T on simple and other metals proposes that the electrical resistivity is constant on the P,T-dependent melting boundary [1,2]. If validated experimentally, this proposal would provide an elegant route to evaluate the electrical resistivity of a metal at very high P,T on its melting boundary by measuring the resistivity on the melting boundary at lower P,T. The present study provides an experimental assessment of this proposal using Cu as a test simple metal.

The theory of electrical resistivity of transition metals in the solid state is generally understood in the context of the nearly free electron model of Ziman's theory [6] has accounted very well for the electrical resistivity of a simple liquid metal like Cu. The transport coefficients in this theory depend on two main factors, namely, the electron-ion pseudopotential matrix element, which describes electron-ion core scattering, and the dynamical structural factor of the ion system. Provided an appropriate electron-ion pseudopotential is used in the NFE model, the electrical resistivity of liquid transition metals can be well described. However for pure liquid transition metals, a different model was suggested by Mott [7], that is similar to the s-d transition model used in his solid state theory [3], but with different mean free paths for the s-p and s-d electrons. Other theoretical studies of electron scattering in liquid transition metals [8–12] have been performed using the transition-matrix term in addition to the electron ion pseudopotential in the Ziman formula [6].

For Cu with filled 3d-band states and with an electronic configuration of [Ar]3d^{10}4s^{1}, the only electron-electron scattering present is s-s scattering, while the conduction s electrons of those metals with an unfilled d-band can undergo both s-s and s-d scattering processes. Electron mobility in the s-band is greater than in the d-band, thus, metals with...
filled $d$-bands are generally more conductive, since $s$-$d$ scattering is absent, than those with unfilled $d$-bands. The delocalised conduction electrons in a metal are subjected to a periodic electron density pattern and hence encounter scattering from it similar to that caused by the pseudopotential of the ion cores [13]. However, in the liquid state, the electron gas is best described outside the ion cores by simple plane waves that are randomly phased and isotropically propagated in a short range ordered structure [13]. In Cu, the filled $d$-band overlaps the bottom of the $s$-band and hence influences the conduction $s$ electrons by shielding them from the influence of the nucleus [14,15] and simultaneously contributes to the periodic electron density of the crystal system.

The interpretation of $P$ effects on the electronic transport of metals generally requires an understanding of the way in which $P$ affects the Fermi surface. The notion that the Fermi surface of solid Cu may touch the Brillouin Zone (BZ) boundary was confirmed by a study of the anomalous skin effect [16]. The energy function changes near the zone boundaries and thus, the Fermi velocity is expected to be lower than its free electron value at the zone boundaries [14]. When a metal is compressed, the volume of the BZ in reciprocal space, and with it the volume enclosed by the Fermi surface, increases. A change in the dimensions of the BZ ideally should cause no topological change in the Fermi surface [17]. The effect of low hydrostatic $P$ on the Fermi surface of solid Cu has been experimentally studied [17,18] by observing the phase change in de Haas van Alphen (dHvA) oscillations in the $P$ range of 0.0001–0.0025 GPa at 1 K and theoretically [19] using ab initio linear muffin-tin orbital method in the atomic sphere approximation. From the rigid-sphere model of liquid metals [20,21], the Fermi surface of many liquid metals is spherical and of volume sufficient to accommodate all the valence electrons. A study on the change of separation of the $d$-band position relative to the Fermi level ($E_{F\text{d}}$) of Cu up to 1.2 GPa at room T, by observing the $P$-dependent shift in the reflectivity edge [22], demonstrated that the $d$-band is unbroadened and unshifted relative to the Fermi level by the process of melting. This suggests that the null effect of $T$ on $E_{F\text{d}}$ at the melting boundary may not compensate for the $P$-induced increase of $E_{F\text{d}}$ in Cu.

The T-dependence of electrical resistivity of solid and liquid Cu at 1 atm as reported by many different authors has been compiled by Matula [24]. The $P$-dependence of electrical resistivity of solid Cu has been studied by both shock wave [25–28] and static [29] $P$ techniques. In order to investigate further the effects of $P$ and $T$ on the electrical resistivity of Cu, particularly in the liquid state, and to test experimentally the thermodynamics-based prediction of constant resistivity on the $P$-dependent melting boundary [1,2], we measured the electrical resistivity of solid and liquid Cu up to 5 GPa and 1730 K. We also performed first principles calculations based on density functional theory (DFT) and the Kubo-Greenwood (KG) approach, to compute the electrical resistivity and the thermal conductivity on liquid Cu on the melting curve at 0 and 5 GPa.

2. Experimental details

Experiments were performed in a 1000-ton cubic anvil press as described elsewhere [30]. The four-wire resistance measurement technique and the cubic pressure cell design are illustrated in Fig. 1. Pyrophylite was used as the P-transmitting medium and the sample pressure was determined from hydraulic oil pressure using prior unpublished calibrations similar to those previously described [30,31]. The dimensions of the Cu wire (99.99% purity, Alfa Aesar) were 0.51 mm in diameter and 1.78 mm in length. The junctions of two W5%Re-W26%Re thermocouples, which also served as 4-wire electrodes, were in direct contact with the ends of the wire sample which was contained in boron nitride (BN). Boron nitride was also used to contain the thermocouples and provided a tight seal at the metal–ceramic interface which helped in containing the liquid above the melting T. The sample length was 0.05 mm longer than the BN sample container which provided good thermocouple/electrode-sample contact. A cylindrical graphite sleeve surrounding the sample container acted as a heat source when a high alternating current was passed through it. A cylindrical zirconia ($\text{ZrO}_2$) sleeve and two ZrO$_2$ disks placed on top and bottom of the sample

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**Fig. 1.** Schematic drawing of two modes (resistance (A) and temperature (B)) of measurement. (A) Four-wire probe design, showing the current polarity switch and the voltmeter for measuring the voltage drop across the sample. (B) Thermocouples measuring the temperature on top and bottom of the sample. (C) SolidWorks™ design of the high-pressure cubic cell (1.25 inch edge length) with the components parts.
3. Theoretical details

First principles simulations were performed using the VASP code [32], with the projector augmented wave (PAW) method [33,34] and the PBE [35] functional. Most calculations were performed with a Cu PAW function. Most calculations were performed with a Cu PAW

3. Results and discussion

Measurements of the T-dependence of the electrical resistivity of Cu at P of 2–5 GPa and at T up to 300 K above the melting point are shown in Fig. 2. In comparison with the recommended 1 atm data by Matula [24], our high P data show very good agreement both in the solid and liquid states and they demonstrate the expected T- and P-effects on resistivity. The abrupt increase in resistivity marks the solid-liquid transition in Cu. The melting T at a fixed P was determined by taking the average of the T measured at the start and completion of melting. Our melting T determined at 2 GPa in this way agrees with previous experimental studies carried out in large volume presses and in diamond anvil cells [45-48] as shown in Fig. 3. However our data show a maximum deviation of ~5.2% at 5 GPa with the average of the other data sets. The melting point differences between our results and the other experimental studies are probably caused by the high rates of heating, polarity switching rate and additional 5 ps Liquid diffusivity was checked throughout by monitoring the mean square displacement. We then constructed an embedded-atom-model (EAM) [38] by fitting the model to the AIMD simulation, following the procedure outlined in Ref. [39]. The form of the EAM was:

\[
E_{\text{out}} = \frac{1}{2} \sum_{i<j} \epsilon \left( \frac{s_{ij}}{a_{ij}} \right)^{\alpha} = \epsilon C \sum_{i<j} \left[ \sum_{i<j} \left( \frac{a_{ij}}{a_{jj}} \right)^{\alpha} \right]^{1/2}
\]

where \(r_{ij}\) is the distance between two atoms at positions \(r_1\) and \(r_2\) and the sums runs for all couple of atoms for which \(r_{ij} < 6.0\). The fitted parameters were = 8.839 \times 10^{-3} \text{ eV}, \alpha = 3.847 Å, \(C = 84.12, n = 8.294, m = 3.493\). We then used the EAM to prepare the liquid for larger systems, including 256, 500, 864 and 1372 atoms. Once the liquids were equilibrated at the desired temperatures we switched to AIMD, performing simulations with a typical length of 20 ps, after discarding the first ps for further equilibration. The DFT-PBE densities at (P,T) = (0.1350 K) and (P,T) = (5 GPa, 1490 K) were 7505 kg m^{-3} and 7970 kg m^{-3}. From these simulations we extracted typically N = 80 configurations, separated by 0.25 ps. These N configurations were then used to compute the electrical and the thermal conductivity via the Kubo-Greenwood [40,41] and the Chester-Thellung-Kubo-Greenwood [42] formula, respectively, as implemented in VASP [43]. The optical conductivities were obtained by averaging over the N configurations \((R; i = 1,N)\) and over k points in the BZ:

\[
\sigma(\omega) = \frac{1}{N} \sum_{n=1}^{N} \frac{1}{k} \sigma_k(\omega, R_i) W(k)
\]

where \(\sigma_k(\omega, R)\) is the optical conductivity for point k and configuration \(R_i\) and \(W(k)\) the weighting factor of the k-point in the BZ. Following [44], we found it convenient to use k-points drawn from the irreducible wedge of the BZ (IBZ) of the same system in which the atoms occupy perfect lattice positions, as convergence with respect to the number of k-points is faster if the points are chosen in this way, provided one averages over the three Cartesian directions. The thermal conductivities were obtained using a similar procedure.

The dc conductivity \(\sigma_0\) is given by the value of \(\sigma(\omega)\) in the limit \(\omega \rightarrow 0\). This limit needs to be taken with care, because at very small values of \(\omega\) conductivity falls unphysically to zero due to the artificial finite spacing between the Kohn-Sham eigenvalues, caused by the finite size of the simulation cell. To take this limit, our procedure is to fit the dc conductivity to a smooth function, without including in the fit values of \(\sigma(\omega)\) that have started to fall to zero. For a simple free electron metal the natural choice would be a Drude model: \(\sigma(\omega) = \sigma_0/(1 + \omega^2\tau^2)\). Although Cu is not a simple metal, and a Drude model would not be appropriate to describe its optical conductivity, we found that by including in the fit a sufficiently restricted set of data in the low energy region of the spectrum the Drude model provided a convenient way to obtain the dc conductivity \(\sigma_0\), and from this the resistivity \(\rho_0 = 1/\sigma_0\).
the positions of the thermocouples which are ~0.7 mm away from the hottest (i.e. central) part of the sample in our experiments. Though measurements were made with one design of pressure cell and strict adherence to one experimental procedure, there were typically slight but significant differences in the geometry between successive sample assemblies after high P and T exposure. These require correction by careful inspection of the recovered sample and measurement of its geometry under microscope as shown in Fig. 4A. These geometry values were used as input into the calculation of the resistivity. It is evident from microprobe analyses of the recovered sample, an example of which is shown Fig. 4B, there was no contamination of the sample either by the electrode/thermocouple or container material. These microprobe results are consistent with the phase diagram of the Cu-W binary system [49] and the absence of any interaction of liquid Cu and Re [50].

As expected, the resistivity of Cu decreases with increasing P in the solid state as shown by the isothermal resistivity behavior at 1350 K in

Fig. 2. Temperature dependence of electrical resistivity of Cu at fixed pressures compared with 1 atm data from several studies as recommended by Matula [24].

Fig. 3. Melting curve of Cu up to 5 GPa, determined by the jump in resistivity in this study, compared with previous studies.

Fig. 5. P-dependence of electrical resistivity of Cu in the solid state along the 1350 K isotherm (open squares) and in the liquid state along the melting boundary (filled squares are experimental; circles are calculation - errors within symbol size). The calculated slopes for the pressure coefficient of resistivity of the experimental data are: 

\[
\frac{d\ln \rho}{dP}_{1350K} = -0.021 \pm 0.003 \text{ GPa}^{-1}
\]

and 

\[
\frac{d\ln \rho}{dP}_{\text{melt boundary}} = -0.017 \pm 0.003 \text{ GPa}^{-1}
\]

Experimental data at 1 atm are from Matula [24].

Fig. 4. (A) Post-mortem view of a sectioned pressure cell recovered from 4 GPa to 1700 K. Thermocouple/electrodes were W5%Re and W26%Re. Measurements of the length and width at several locations of the ground Cu sample are labelled. (B) Back scattered electron image of a sample recovered from 2 GPa, 1503 K along with tabulated electron microprobe results of probe points 6–10. The white scale bar is 100 μm.
Fig. 5. The electronic structure of Cu has been very well investigated both experimentally and theoretically [51–58]. Studies have shown that the interaction between the high-lying 3d-band and the s conduction band leads to appreciable distortion of the Fermi surface of Cu from a perfect sphere, giving rise to neck features [15,59]. Experiments probing the dHvA oscillations of the magnetic susceptibility and theoretical studies on the effect of P on the Fermi surface of Cu have shown that the neck section increases relative to the bellies [17–19]. The increased distortion of the Fermi surface with P promotes zone boundary scattering which diminishes the mean free path of the electrons near the Fermi energy and enhances the electrical resistivity. However on any given isotherm, the effect of P-induced increase of $E_{\text{eq}}$ [22], which decreases the scattering caused by the reduced influence of the periodic electron density on the conduction s electrons as well as the P-induced reduction of the phonon amplitude, causes a net decrease in resistivity in the solid state.

The resistivity at the solid-liquid phase transition doubles in value as shown in the resistivity ratio plotted versus P in Fig. 6. Other metals similar to Cu in crystal and electronic structure, such as Ag and Au, show similar doubling of the resistivity on melting at 1 atm [24]. From the NFE model [6], the relative change in electrical resistivity during melting is similar doubling of the resistivity on melting at 1 atm [24]. From the NFE model, the relative change in electrical resistivity during melting is proportional to the increase in electrical resistivity on melting at 1 atm. However, there does not appear to be a P-dependent trend in any of the temperature data sets. There is no indication in the T-coefficient of resistivity behavior that would suggest a P-induced change in structure of Cu in either the solid or liquid state, in agreement with the phase diagram of Cu reported up to 6 GPa [60].

As shown in Fig. 5, the P-coefficient of resistivity on the melting boundary, $\frac{\partial \ln \rho}{\partial P}_{\text{melt boundary}}$ is approximately $-0.017 \pm 0.003 \text{ GPa}^{-1}$, and the P-dependence of the resistivity ratio of liquid to solid at the melting point doubles in value as shown in the resistivity ratio plotted versus P in Fig. 6. Least squares fit ($r^2 = 0.998$) yields $\rho_{\text{liq}}/\rho_{\text{sol}} = 2.072 \pm 0.0457(0.0006) \text{ GPa}^{-1}$.

Fig. 7. The T coefficient ($\partial \ln \rho / \partial T$) of electrical resistivity plotted for liquid Cu and three temperature ranges in the solid state for P range of 2–5 GPa. Comparison is made with $\partial \ln \rho / \partial T$ derived from the 1 atm data of many studies as compiled by Matula [24]. Error bars are provided or are within the symbol size.

\begin{equation}
\frac{\partial \ln \rho}{\partial P}_{1350K} = \frac{-2(\gamma - 1/3)}{K_T}
\end{equation}

where $\gamma$ is the Grüneisen parameter and $K_T$ is the isothermal bulk modulus. We estimate $\gamma$ to be 1.5 for solid Cu at 1350 K from the 1.96 room T measurement by Chatterjee [61] and applying T-dependence of $\gamma$ by Singh [62]. With a $K_T$ value of 134 GPa at 300 K, we extrapolate $K_T$ to 1350 K from the T-dependence of $K_T$-measured up to 800 K by Chang and Himmel [63], to be 93.7 GPa and calculate a value of $-0.025 \text{ GPa}^{-1}$ for $\frac{\partial \ln \rho}{\partial P}_{1350K}$ from Eqn (3). The prediction of $\frac{\partial \ln \rho}{\partial P}_{1350K}$ by Eqn (3) compares well with our measured experimental value. However, the value of $\frac{\partial \ln \rho}{\partial P}_{1350K}$ is not equal to zero which does not support the conclusion that the electrical resistivity of an electronically simple metal such as Cu is constant on the P,T-dependent melting boundary [1,2]. Our experimental findings suggest that although electron scattering increases with both T at the melting point and with structural disorder that accompanies melting, the integrated effects of increasing P on electron scattering on melting results in an overall decrease in electrical resistivity along the melting boundary. This is clearly shown in Fig. 6 where the ratio of the liquid to solid resistivity values at the melting point is plotted versus P. With nearly constant solid resistivity just below the melting point (10.1–10.5 $\times$ 10$^{-6}$ $\Omega$cm) as demonstrated in Fig. 2, the decreasing resistivity in the liquid at the melting point with increasing P causes an overall decrease in the resistivity ratio.

In Fig. 8 we show the theoretical DFT-KG resistivities computed on the melting curve at ambient pressure and at a pressure of 5 GPa, as function of the size of the simulation cell. Convergence to better than $\sim 3\%$ is obtained with simulation cells including 500 atoms or more, and there is little difference between calculations performed with either 4 or 10 k-points. Statistical error bars were obtained from the spread of the values of the resistivities for each of the N configurations included in the calculations. The converged values are also reported in Fig. 5, which shows agreement with the experimental values to within 16%, and confirm the decrease of resistivities as function of pressure on the melting...
The electronic thermal conductivity, $k_e$, of Cu was calculated from our experimental electrical resistivity data using the Wiedemann-Franz law and the Sommerfeld value of $L = 2.445 \times 10^{-8} \text{V}^2/\text{K}^2$.

The electronic thermal conductivity, $k_e$, of Cu was calculated from our experimental electrical resistivity data using the Wiedemann-Franz law and the Sommerfeld value of $L = 2.445 \times 10^{-8} \text{V}^2/\text{K}^2$. The T-dependence of $k_e$ at four P values is shown in Fig. 10. We compare our results of $k_e$ with those calculated in the same way using the 1 atm electrical resistivity data of Matula [24]. As expected, $k_e$ decreases with increasing T in the solid state. On melting, $k_e$ decreases to approximately half of its solid state value and in the liquid state $k_e$ increases slightly with T. With increasing P, $k_e$ increases both in the solid and liquid states.

The calculated electronic contribution to the thermal conductivities and state and $\pm 15\%$ in the liquid state [67]. The 1 atm experimental values of $k_{\text{total}}$ are lower than the values of $k_e$ calculated from electrical resistivity using the Wiedemann-Franz Law. This is unexpected since $k_{\text{total}}$ is the sum of $k_e$ and $k_p$. This suggests that the Sommerfeld value of the Lorenz number may not be valid for Cu at these T as shown for other metals [73].

The insert plot in Fig. 10 indeed shows that the experimentally derived Lorenz number may not be valid for Cu at these T as shown for other metals [73]. The insert figure shows the T-dependence of the measured Lorenz number for Cu [Laubitz [66]].
are 137.5 (4) and 152.5 (5) W m$^{-1}$K$^{-1}$, from which we obtain values for the Lorentz number of 2.367(14) $\times 10^{-8}$ and 2.347(18) $\times 10^{-8}$ at 0 GPa, 1350 K and 5 GPa, 1490 K, respectively. Both sets of values are in good agreement with values derived from experimental measurements as shown in Fig. 10. The calculated Lorentz number values are somewhat lower than the Sommerfeld value of 2.443 $\times 10^{-8}$ W m$^{-1}$K$^{-1}$, and are constant on the melting curve within statistical error.

As shown in Fig. 11, the P-dependence of $k_e$ is plotted at, 1350 K and at melt. We calculate a P-coefficient of $k_e$, ($\frac{\partial (ln k_e)}{\partial P}$)$_{melt}$ of 0.038±0.002 GPa$^{-1}$ and ($\frac{\partial (ln k_e)}{\partial P}$)$_{1350K}$ of 0.021±0.003 GPa$^{-1}$ from our data. We compare this value with the same parameter calculated using the relationship derived by Bohlin [74] given in Eqn (4), which is similar to Eqn (1) for electrical resistivity:

$$\frac{\partial (\ln k_e)}{\partial P} = \frac{2\gamma - 1/3}{kT}$$

(4)

We calculate a value of 0.038 GPa$^{-1}$ for $(\ln k_e/\partial P)_{1350K}$ from Eqn (4). The prediction of $(\ln k_e/\partial P)_{1350K}$ by Eqn (4) is reasonably close to our measured value. Our experimental findings suggest that although electron mobility decreases with both T on the melting boundary and with structural disorder that accompanies melting, the integrated effects of increasing P on $k_e$ on melting results in an overall increase in $k_e$.

5. Conclusions

The T-dependence of electrical resistivity of Cu in both solid and liquid states has been investigated up to P of 5 GPa. Our results show that the electrical resistivity at the melting T decreases as a function of P in contrast to prediction. These findings are interpreted in terms of the antagonistic effects of P and T on the electronic structure of liquid Cu as demonstrated in previous studies and reviewed in the introduction section of this manuscript. The electronic component of thermal conductivity increases with P both in the solid and liquid states and at fixed P, it decreases as a function of T in the solid state, but increases with T in the liquid state. Comparison of the calculated electronic thermal conductivity and experimentally measured total thermal conductivity at 1 atm indicates that phonon conductivity is very low in Cu. Within experimental error, our melting T at P values up to 5 GPa are in agreement with previous experimental studies.

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References


Fig. 11. $P$-dependence of thermal conductivity of Cu at 1350 K and along the melting boundary. The calculated slopes for the pressure coefficient of electronic thermal conductivity $k_e$ of the fitted lines are $\ln (k_e/\partial P)_{1350K} = (0.021 \pm 0.003)$ GPa$^{-1}$ and $\ln (k_e/\partial P)_{melt} = (0.038 \pm 0.002)$ GPa$^{-1}$. The T-dependence of electrical resistivity of Cu in both solid and liquid states has been investigated up to P of 5 GPa. Our results show that the electrical resistivity at the melting T decreases as a function of P in contrast to prediction. These findings are interpreted in terms of the antagonistic effects of P and T on the electronic structure of liquid Cu as demonstrated in previous studies and reviewed in the introduction section of this manuscript. The electronic component of thermal conductivity increases with P both in the solid and liquid states and at fixed P, it decreases as a function of T in the solid state, but increases with T in the liquid state. Comparison of the calculated electronic thermal conductivity and experimentally measured total thermal conductivity at 1 atm indicates that phonon conductivity is very low in Cu. Within experimental error, our melting T at P values up to 5 GPa are in agreement with